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APPLICANTS Naoto Kusumoto, Kanagawa, JAPAN; Shunpei Yamazaki, Tokyo, JAPAN;  ** CONTINUING DATA **********************************									
Foreign Priority claimed Yes no STATE OR SH					EETS TOTA AWING CLAI 8 20		MS	INDEPENDENT CLAIMS 5	
26171 TITLE  Method for producing insulated gate thin film semiconductor device									
FILING FEE FI RECEIVED N 1860 N	EES: Authority has been given in Paper o to charge/credit DEPOSIT ACCOUNT o for following:				All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit				